

MAY 29 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Shunpei YAMAZAKI

Serial No. 09 620,968

Filed: July 20, 2000

For: METHOD OF FORMING INSULATING FILMS,
CAPACITANCES, AND SEMICONDUCTOR
DEVICES

)

) Group Art Unit: 2814

) Examiner: Nathan W. Ha

) Confirmation No. 4214

) Date: May 29, 2003

RESPONSE TO RESTRICTION REQUIREMENT/AMENDMENT

Mail Stop Non-Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Request for Restriction mailed April 29, 2003, please amend the above identified application as follows.

IN THE CLAIMS:


Please delete claim 1 without prejudice of disclaimer to file a divisional application directed thereto.

REMARKS

Applicants hereby elect without traverse Group II (claims 2-22), drawn to a method of making a semiconductor device, classified in class 438, subclass 123.

Consideration and allowance of the instant application are now respectfully requested.

Respectfully submitted.


Jeffrey L. Costellia
Registration No. 35,483

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, VA 22102
(703) 770-9300